



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823
Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicant(s) : Junichi HIKITA et al.

Serial No. : 10/626,524)

Filed : July 25, 2003)

For : Method of producing a semiconductor
Device by dividing a semiconductor wafer
Into separate pieces of semiconductor chips
(as amended)

Attorney Ref: AI 290 D1

STATUS REQUEST

January 10, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an Action may be expected. If the response to this status request is made by telephone, please ask for Tonya Harris (Docket Clerk) at extension 518.

Respectfully submitted,

January 10, 2006
Date

SMR:ss

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